

Notice of References CitedApplication No.
09/357,264Applicant(s)
Zhang et al.Examiner
Charlotte A. BrownGroup Art Unit
1765

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	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS
A	6,063,306	5/2000	Kaufman et al.	252	79.4
B	5,645,736	7/1997	Allman	216	89
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M					

FOREIGN PATENT DOCUMENTS

	DOCUMENT NO.	DATE	COUNTRY	NAME	CLASS	SUBCLASS
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U	J.Grossman and D.S. Herman, "A New Etchant for Thin Films of Tantalum and Tantalum Compounds", Journal of Electrochemical Society, Vol. 116, No.5, p.674 and cover page.	5/1969
V	K.S. Indira and B.A. Shenoi, "Chemical Polishing of Metals: A Study", Central Electrochemical Research Institute, p.80-91 including cover page.	8/1973
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